

All-oxides heterojunctions: growth and characterization by photoelectron spectroscopies

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Recent advances in the growth of epitaxial oxide thin films have fostered a steady increase of research on perovskite oxide heterojunctions, which are now produced with unprecedented quality. All-oxide perovskite interfaces can be regarded as a platform for synthetic quantum matter, offering a wide range of complex magnetic, transport and correlation-related physical properties. Applications of these ultra-thin interfaces in the field of electronics, photon harvesting, photovoltaics and photocatalysis strongly rely on the capability to master band gap engineering at the nanoscale.

X-ray photoemission spectroscopies (XPS) are playing a key role in the investigation of electronic and structural properties of all-oxide heterointerfaces [1]. Core level and valence band XPS can be combined to probe the band gap alignment [2]. The use of tunable light sources allow to change the in-depth sensitivity, with the possibility to profile the band-gap close to the interface and to compare the results with bulk electronic states [3]. Finally, the spectral weight enhancement obtained by tuning the photon energy [4], has disclosed unexpected possibilities in the study of band dispersion at buried interfaces.

Here, the combination of these techniques is focused on the study of oxide thin film grown on SrTiO₃ (001), as these systems can host a two dimensional electron gas (2DEG) at the interface and display magnetic ordering and superconductivity effects, disclosing possible applications in the next-generation nanoelectronic devices. We will show how RF sputtering technique can be used to effectively grow high quality, epitaxial ultrathin (< 2 nm) films, with both perovskite and non-perovskite crystal structure; in particular, we will discuss the use of X-ray photoelectron diffraction as a tool of film crystal order assesment [5]. Finally, the junction band diagrams obtained with XPS will be discussed in detail, through the comparison of review of several theoretical and experimental results [6].

References

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